

model multilayer stack and thickness and refra

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DL Windt - Computers in Physics, 1998 - cletus.phys.columbia.edu

... th and the j th layers in a multilayer stack, where we ... stack, starting at the bottom-most layer (i = N, j = s ... in IMD it's also possible to model the effects ...

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J Winn S Fan

Y Fink

C Chen

J Michel

Electrically tunable optical filter utilizing a deformable multi-layer mirror - group of 2 »

P Tayebati - US Patent 5,739,945, 1998 - Google Patents

... layers (3.5 and 1), the resulting multilayer GaAlAs/air ... Instruments' top-of-the-line model costs above ... 6 shows the cross section of a multi-layer device before ...

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Optical Analysis of Complex Multilayer Structures Using Multiple Data Types - group of 6 »

B Johs, RH French, FD Kalk, WA McGahan, JA Woollam - SPIE Proc, 1994 - Irsm.upenn.edu

... The beam propagates coherently through the multilayer film stack, resulting in a ...

1) are readily calculated using the optical model formalism described in ...

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A Dielectric Omnidirectional Reflector - group of 8 »

Y Fink, JN Winn, S Fan, C Chen, J Michel, JD ... - Geophys. Res. Lett, 1998 - rpi.edu ... aerosol forcing used in the UD **model**, we considered ... 1. Schematic of the **multi-layer** system showing the ... A) Projected band structure of a **multilayer** film with ...

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... -light interferometry for absolute distance measurement with dielectric multilayer systems

on the ... - group of 6 »

U Schnell, R Dändliker, S Gray - Opt. Lett, 1996 - OSA

... that describes the effects of multiple reflections within the **stack**. ... tion of a more general **model** of the phase contribution of the **multilayer** system 12 ...

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Giant Birefringent Optics in Multilayer Polymer Mirrors - group of 10 »

MF Weber, CA Stover, LR Gilbert, TJ Nevitt, AJ ... - Science - 0-www.sciencemag.org.library.vu.edu.au

... 4. An AFM image of a GBO stack (31); the dark-colored layers are PMMA ... n 2 y , and n 2 z as input for a multilayer interference optical film model. ...

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Multilayer Waveguide-Grating Filters - group of 6 »

SS Wang, R Magnusson - Appl. Opt, 1995 - OSA

... The antireflection properties of the **layer stack** can be ... are based on a general mathematical **model** for a ... can be converted to a **multilayer** resonance-location ...

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Efficient, high-bandwidth organic multilayer photodetectors - group of 3 »

P Peumans, V Bulović, SR Forrest - Applied Physics Letters, 2000 - rle.mit.edu

... PL of one material PTCBI in the **multilayer stack**. ... able to **model** the temporal response, obtaining an ... that organic alter- nating **multilayer** photodetectors can be ...

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Electrically tunable fabry-perot structure utilizing a deformable multi-layer mirror and method of ... - group of 6 »

P Tayebati - US Patent 6,324,192, 2001 - Google Patents

... MIRROR PA'S WERE USED IN EACH STACK OF THE ... FABRY-PEROT STRUCTURE UTILIZING A DEFORMABLE

MULTI-LAYER MIRROR AND ... on a novel 25 broad-band multilayer GaAlAs/air ...

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Deposition of multiple layer thin films using a broadband spectral monitor - group of 2 » WH Southwell, RL Hall - US Patent 5,425,964, 1995 - Google Patents ... the the 50 computed reflectance 45 to the single layer model. ... If the multilayer film is not complete at step 51 ... When all layers ofthe multi -layer film have been ... Cited by 20 - Related Articles - Web Search

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